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Γ	APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
_	10/684,431	10/15/2003	Gurtej S. Sandhu	M4065.0316/P316-A	3910	
	24998	24998 7590 06/20/2005			EXAMINER	
	DICKSTEIN 2101 L Street	SHAPIRO MORIN	GHYKA, ALEXANDER G			
	Washington,			ART UNIT	PAPER NUMBER	
	υ,			2812		

DATE MAILED: 06/20/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

The second

*		Application No.	Applicant(s)						
	Office Action Commons	10/684,431	SANDHU ET AL.						
	Office Action Summary	Examiner	Art Unit						
		Alexander G. Ghyl							
	The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply								
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).									
Status									
1)⊠	1) Responsive to communication(s) filed on 12 April 2005.								
•	·	This action is non-final.							
3)	Since this application is in condition for al	llowance except for form	al matters, prosecution as to th	e merits is					
	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.								
Disposition of Claims									
4)🖂	Claim(s) 13-14, 16-22, 24-29 and 31-65	is/are pending in the app	plication.						
	4a) Of the above claim(s) 46-65 is/are with	hdrawn from considerati	on.						
5)	Claim(s) is/are allowed.			ER GHYKA					
	Claim(s) <u>13,14,17-22,25-29 and 32-45</u> is/	are rejected.	PRIMARY	EXAMINER					
· —	Claim(s) <u>16,24 and 31</u> is/are objected to. Claim(s) are subject to restriction a	and/or election requirem	election requirement.						
	Application Papers Application Papers								
9) 🗌 🤈	The specification is objected to by the Exa	aminer.	~ ,	` // //					
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.									
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).								
11) 🗌	11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
Priority u	under 35 U.S.C. § 119								
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this National Stage 									
application from the International Bureau (PCT Rule 17.2(a)).									
* See the attached detailed Office action for a list of the certified copies not received.									
Attachment	t(s)								
	e of References Cited (PTO-892)	4) 🔲 <u>I</u> n	terview Summary (PTO-413)						
3) Inform	e of Draftsperson's Patent Drawing Review (PTO-94 mation Disclosure Statement(s) (PTO-1449 or PTO/S r No(s)/Mail Date	SB/08) 5) 🔲 N	aper No(s)/Mail Date otice of Informal Patent Application (PT ther:	O-152)					

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DETAILED ACTION

Applicants' response of 4/12/2005 has been received and made part of the record. Claims 13, 21, 28 and 44 have been amended. Claims 46-55 have been added. Claims 46-55 are withdrawn from consideration by election by original presentation as discussed below. Therefore, Claims 13-14, 16-22, 24-29 and 31-45 are now under consideration. The following new rejections are made. Accordingly this Office action is a non-Final rejection.

Election by Original Presentation

Newly submitted claims 46-55 are directed to an invention that is independent or distinct from the invention originally claimed for the following reasons: the claims require an interconnection layer and two impurity regions, which were not required in the Claims as originally filed.

Since applicant has received an action on the merits for the originally presented invention, this invention has been constructively elected by original presentation for prosecution on the merits. Accordingly, claims 46-55 are withdrawn from consideration as being directed to a non-elected invention. See 37 CFR 1.142(b) and MPEP § 821.03.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

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(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 13-15, 17, 19 and 44-45 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tsai (US Patent No. 5,981, 398) in view of Fiordalice et al (US 5,534,462), Tanaka et al (US 5,733,712) and Miller (US Patent No. 4,722,913).

Tsai discloses a method for forming a patterned layer in microelectronic fabrication. Blanket target layer 12 is formed on substrate 10. Blanket silicon oxide layer 13 is formed over layer 12 and serves as an antireflective coating. The ARC layer is preferably formed from about 300-1000 angstroms (column 6, lines 30-44). Blanket hard mask layer 14 is then formed over ARC layer 13. Hard mask layer 14 is preferably formed from a sisequioxane spin-on-glass (SOG) material (the claimed layer which is transparent to the wavelength of light) at a thickness of about 2000-4000 angstroms (column 7, lines 23-26). Therefore, the layer of the thickness of the transparent layer is greater than the thickness of the ARC layer, as required in the present limitations. Patterned photoresist layers 16a, 16b and 16c are formed preferably using DUV light (248 nm) and then used as an etch mark to pattern the underlying layers (column 8, 10-44). Tsai et al disclose that the ARC layer has a smaller thickness than the transparent layer on it as required by the amended claims. With respect to the limitations in Claim 44-45, two sublayers of silicon as required by the present claims do not patentably differentiate over one layer of silicon as disclosed by the Tsai reference.

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However Tsai does not disclose using BPSG, PSG or TEOS as the transparent layer or providing a silicon oxide layer over a surface of the substrate.

Fiordalice teaches that plasma enhanced oxide, BPSG, PSG, TEOS and SOG are all known silicon oxide based dielectric equivalents conventionally used in the art for interlayer dielectric materials. See column 1, lines 42-45 and column 4, lines 27-29.

Tanaka et al disclose a resist pattern forming method using an antireflective layer. Tanaka et al is simply relied upon to show that SOG and PSG layers are transparent to light having a wavelength of 248 and 365 nm. See column 11, lines 28-33, column 12, lines 18-25, column 20, lines 30-35, column 22, lines 30-35.

Therefore, it would have been obvious to one of ordinary skill in the art to use BPSG, PSG or TEOS as the transparent layer in the method of Tsai, instead of the SOG as taught by Tsai, because Fiordalice teaches that all are silicon oxide based equivalents which are conventionally used as interlayer dielectric materials. The transparency of these layers would be obvious in view of the teaching of the Tanaka et al reference.

While Tsai does not disclose that a silicon oxide layer is provided over a surface of the substrate, the reference does teach that the substrate may have formed thereon additional microelectronics layers which are conventional in the art, such as microelectronic dielectric layers (column 5, lines 19-45). Miller teaches that it is conventional in the art to provide an insulating film over a semiconductor substrate in order to insulate the substrate devices from the overlying metal layers and that typically this insulating layer is silicon oxide (column 1, lines 56-63).

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Therefore, it would have been obvious to one of ordinary skill in the art to provide a silicon oxide layer (as a microelectronics dielectric layer) over the substrate in the method of Tsai because Miller teaches that it is known in the art to provide an insulating layer of silicon oxide over a substrate for the benefit of insulating the substrate and its devices from the overlying metal layers.

Claims 21-23, 26, 28-30, 36 and 44-45 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tsai in view of Fiordalice, Tanaka and Miller as applied to claim 13-17, 19 and 44-45 above, and further in view of Applicants' Own Admission in the Present Specification.

Tsai, Fiordalice, Tanaka and Miller are relied upon as discussed above.

Tsai discloses exposing the photoresist to DUV (248 nm) but does not disclose exposing the photoresist to light at a wavelength of 193 or 365 nm.

Applicants' own specification teaches that in addition to DUV (248 nm), mid-UV (365 nm) and extreme UV (193 nm) are also conventional radiation sources used in the art (See Background Section of the present Specification).

It would have been obvious to one of ordinary skill in the art, at the time of the invention, to expose the photoresist in the method of Tsai in view of Fiordalice, Tanaka and Miller to light at a wavelength of 193 nm or 365 nm, instead of 248 nm, for their known benefit as conventional radiation sources used to expose photoresist in the art as disclosed by Applicants' own specification. Therefore, a prima facie case of obviousness is established.

Claims 18, 20, 25, 27, 32, 34-35 and 37-45 are rejected under 35
U.S.C. 103(a) as being unpatentable over Tsai in view of Fiordalice, Tanaka, Miller and Applicants' Own Admission as applied to claim 13-17, 19, 21-24, 26, 28-31, 36 and 44-45 above, and further in view of Jain et al. (US 5,741,626).

Tsai, Fiordalice, Mille, Tanaka and Applicants' Own Admision are relied upon as discussed above.

However, the cited references do not disclose anti reflective layers made out of silicon and nitride or the use of a second antireflective layer.

Jain et al discloses the use of silicon nitride as an antireflective layer (column 1, lines 35-40) and discloses the use of a second antireflective layer (column 6, lines 60-65 and column 9, lines 30-40).

It would have been obvious for one of ordinary skill in the art to make an anti reflective layer out of silicon nitride and use a second antireflective layer in a method as disclosed by Tsai et al, Fiordalice, Tanaka, Miller and Applicants' Own Admission for its known benefit as a barrier layer. As silicon nitride is a known material for making anti reflective layer, and the use of two anti reflective layers is known in the art as disclosed by the Jain et al reference, a *prima facie* case of obviousness is established.

Allowable Subject Matter

Claims 16, 24 and 31 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the

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limitations of the base claim and any intervening claims. The cited prior art does not disclose a transparent layer comprising BPSG, PSG or TEOS in addition to an oxide.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alexander G. Ghyka whose telephone number is (571) 272-1669. The examiner can normally be reached on Monday through Thursday during general business hours.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Lebentritt can be reached on (571) 272-1873. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

AGG June 15, 2005

ALEXANDER GHYKA PRIMARY EXAMINER